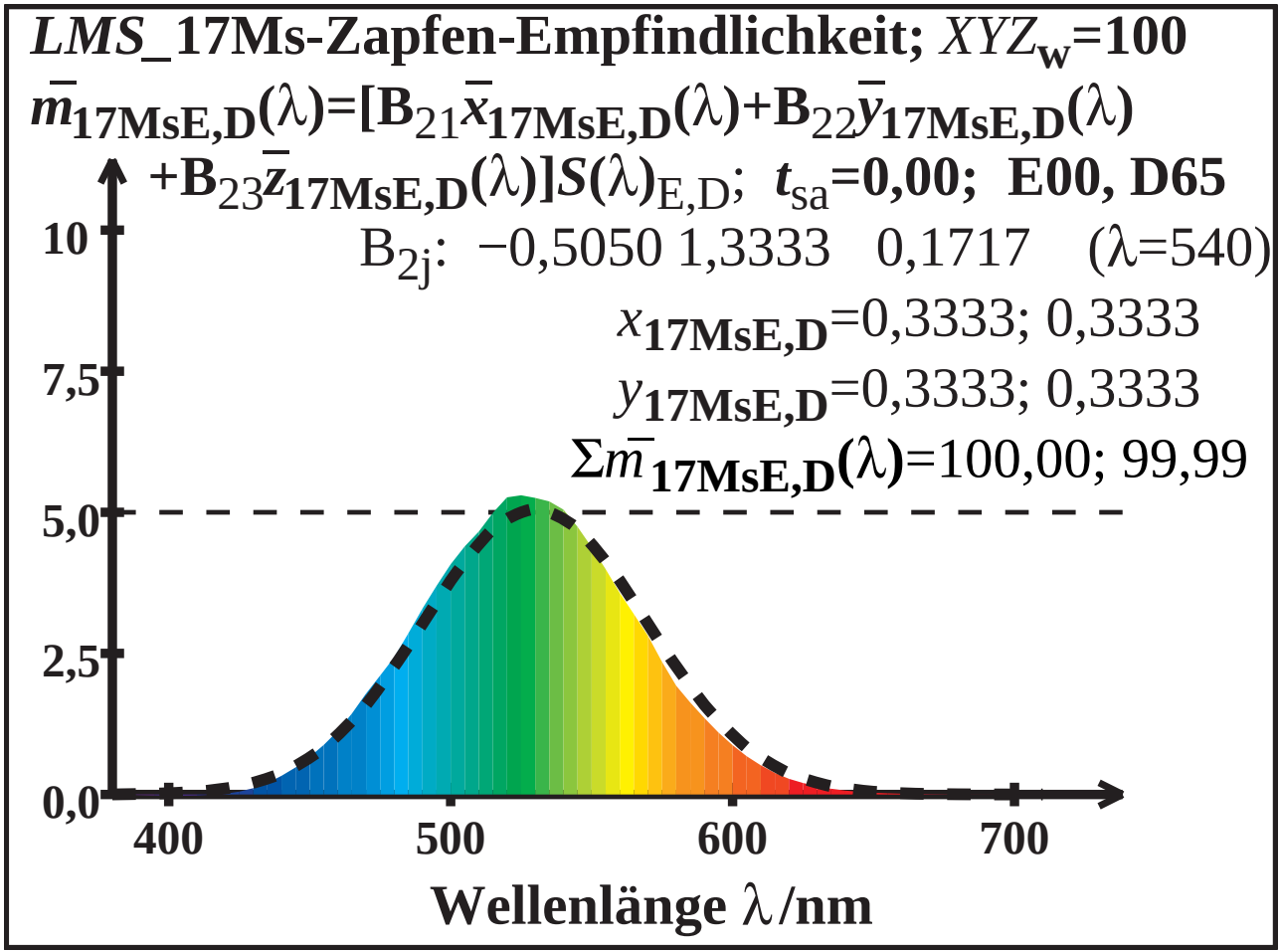
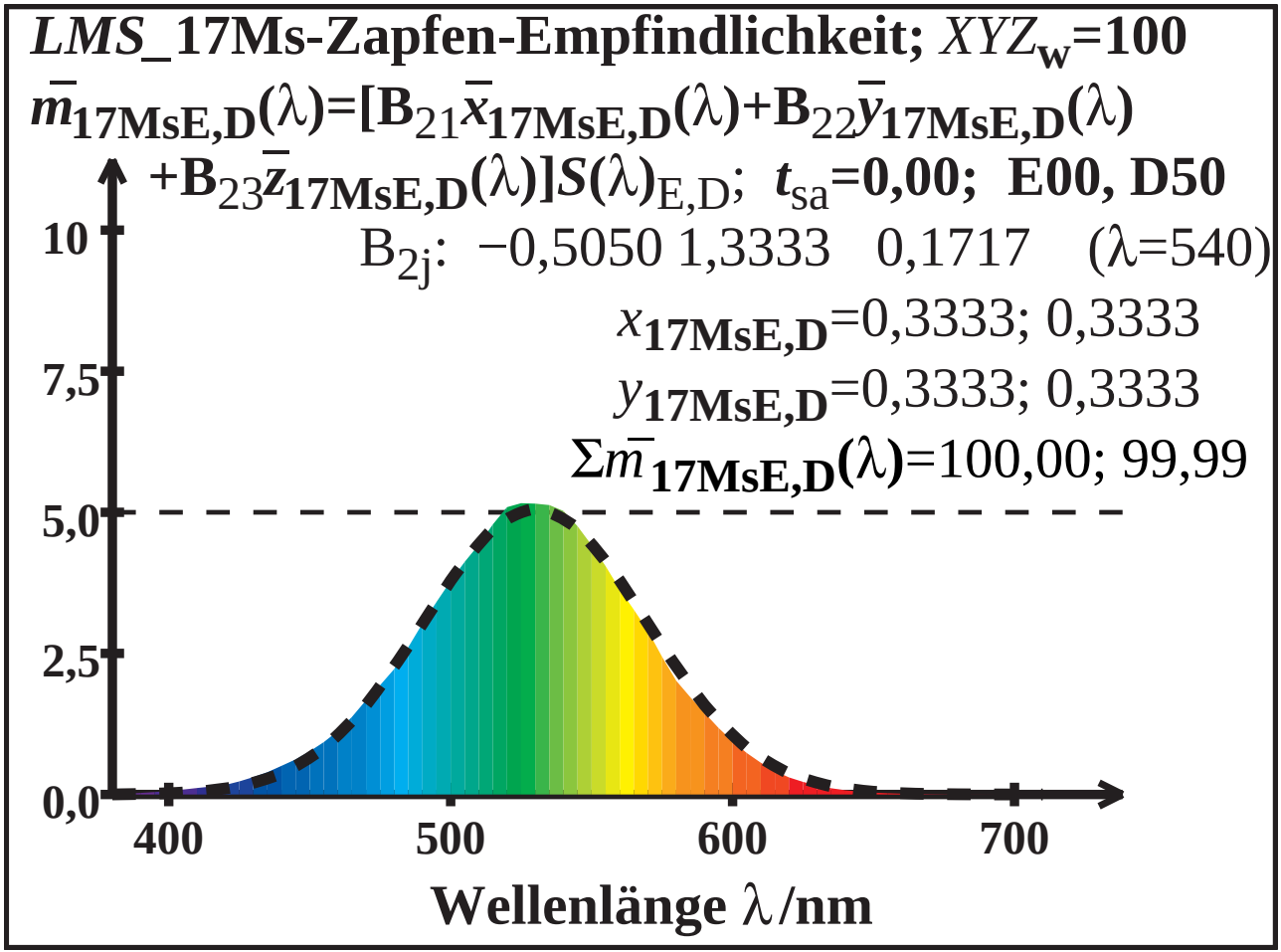
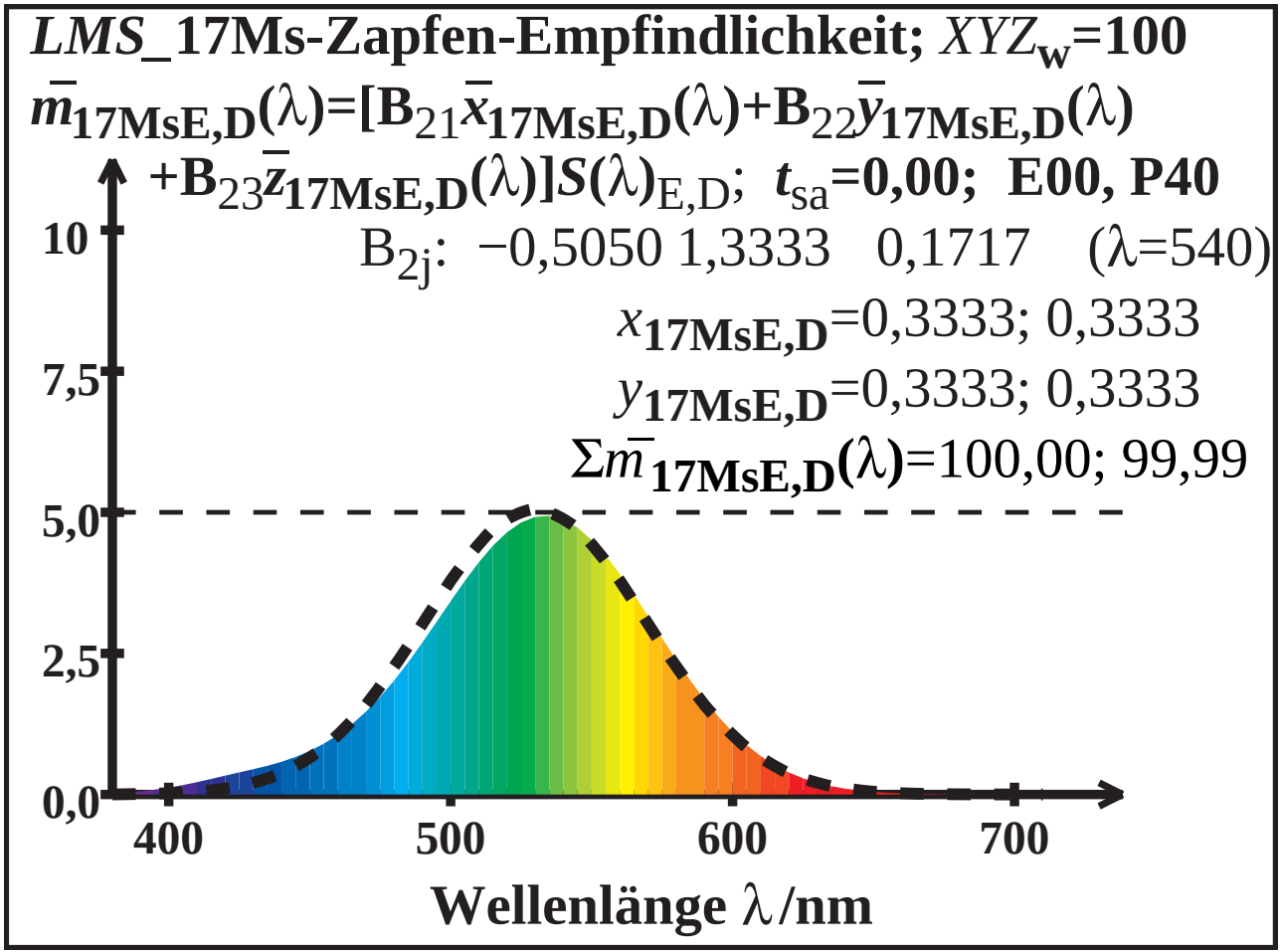

LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m̄17MsE,D(λ)=[B21x̄17MsE,D(λ)+B22ȳ17MsE,D(λ)
+B23z̄17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, D65
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm̄17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

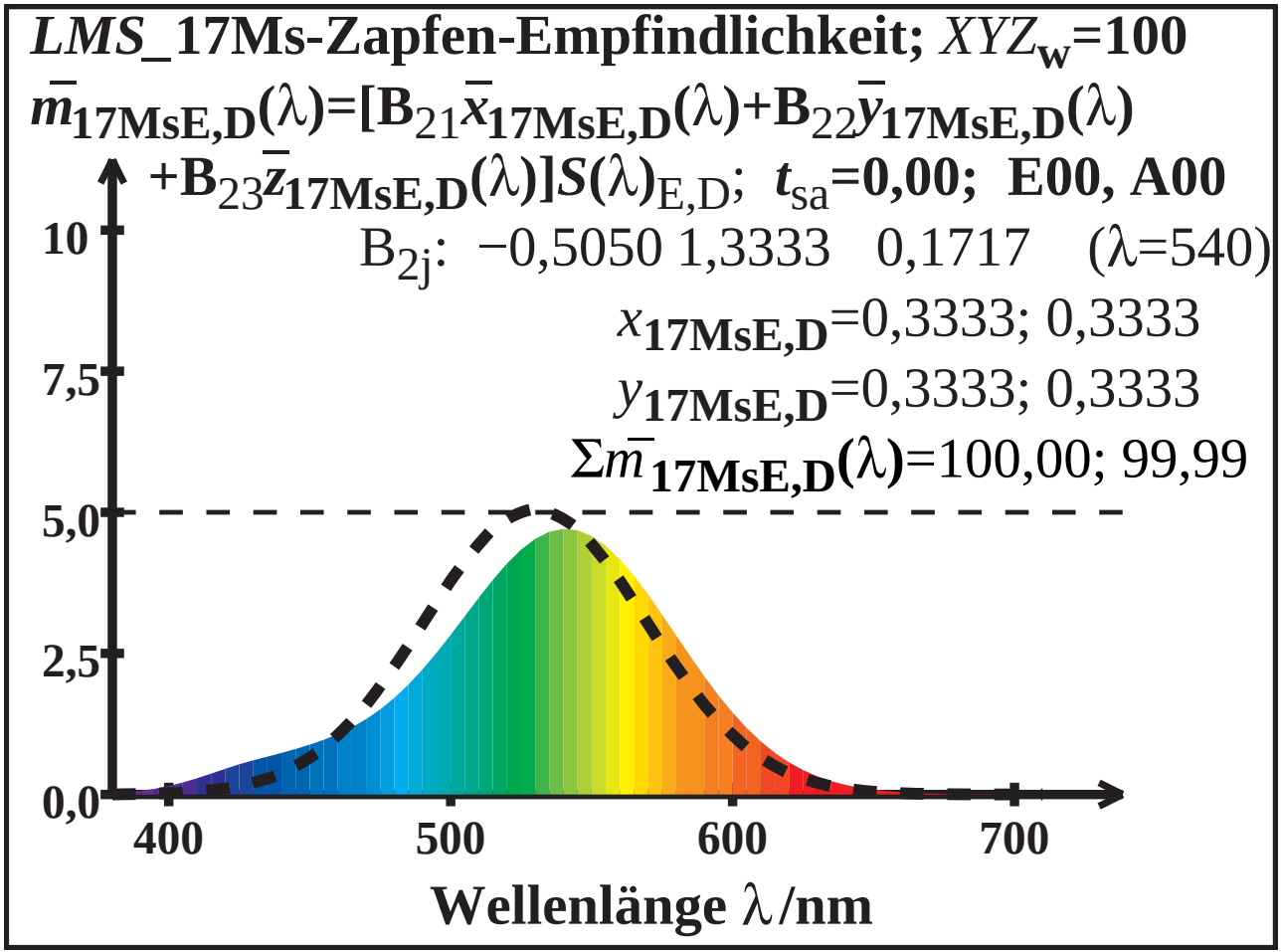
CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, D50
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

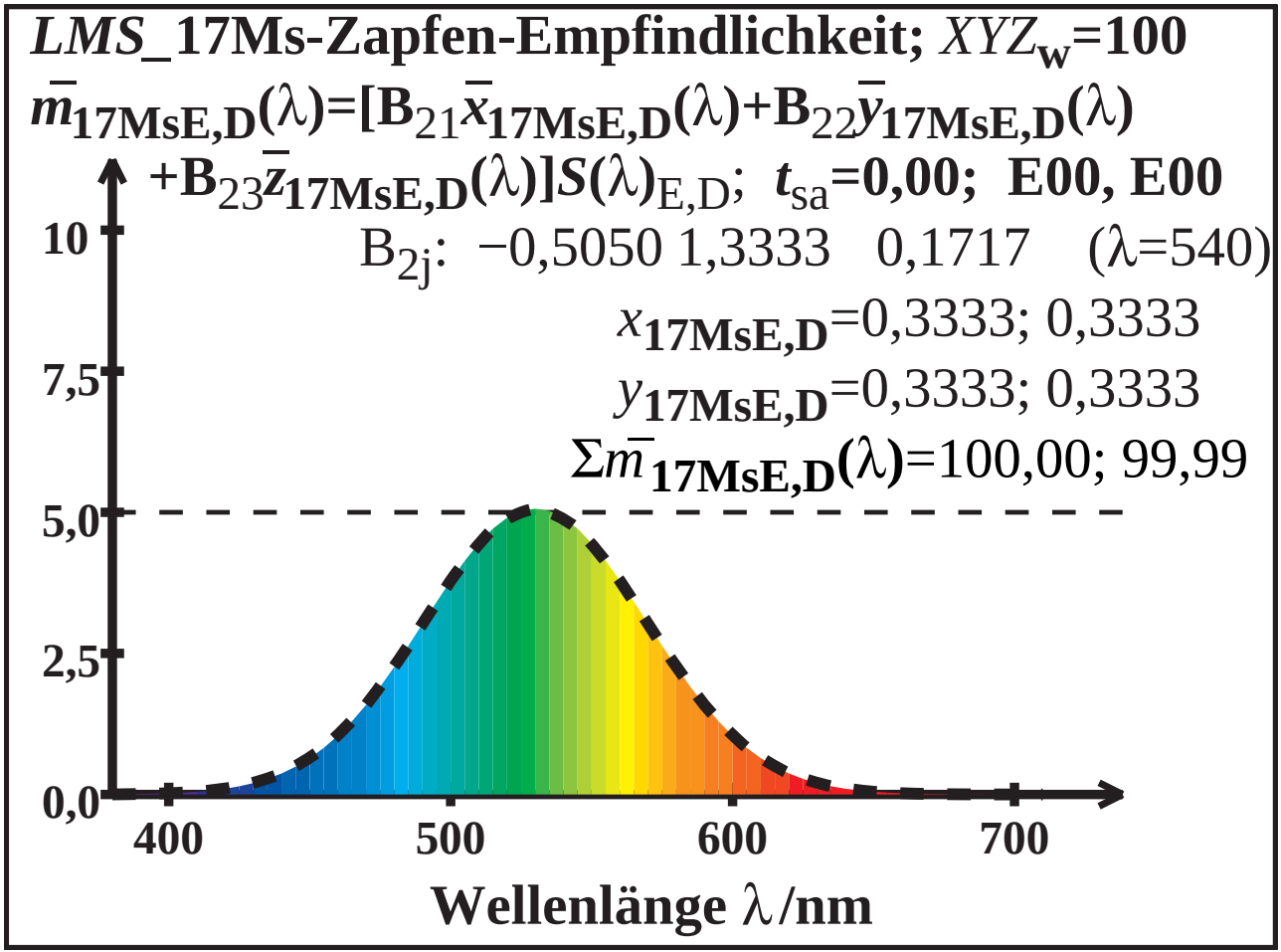
CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, P40
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

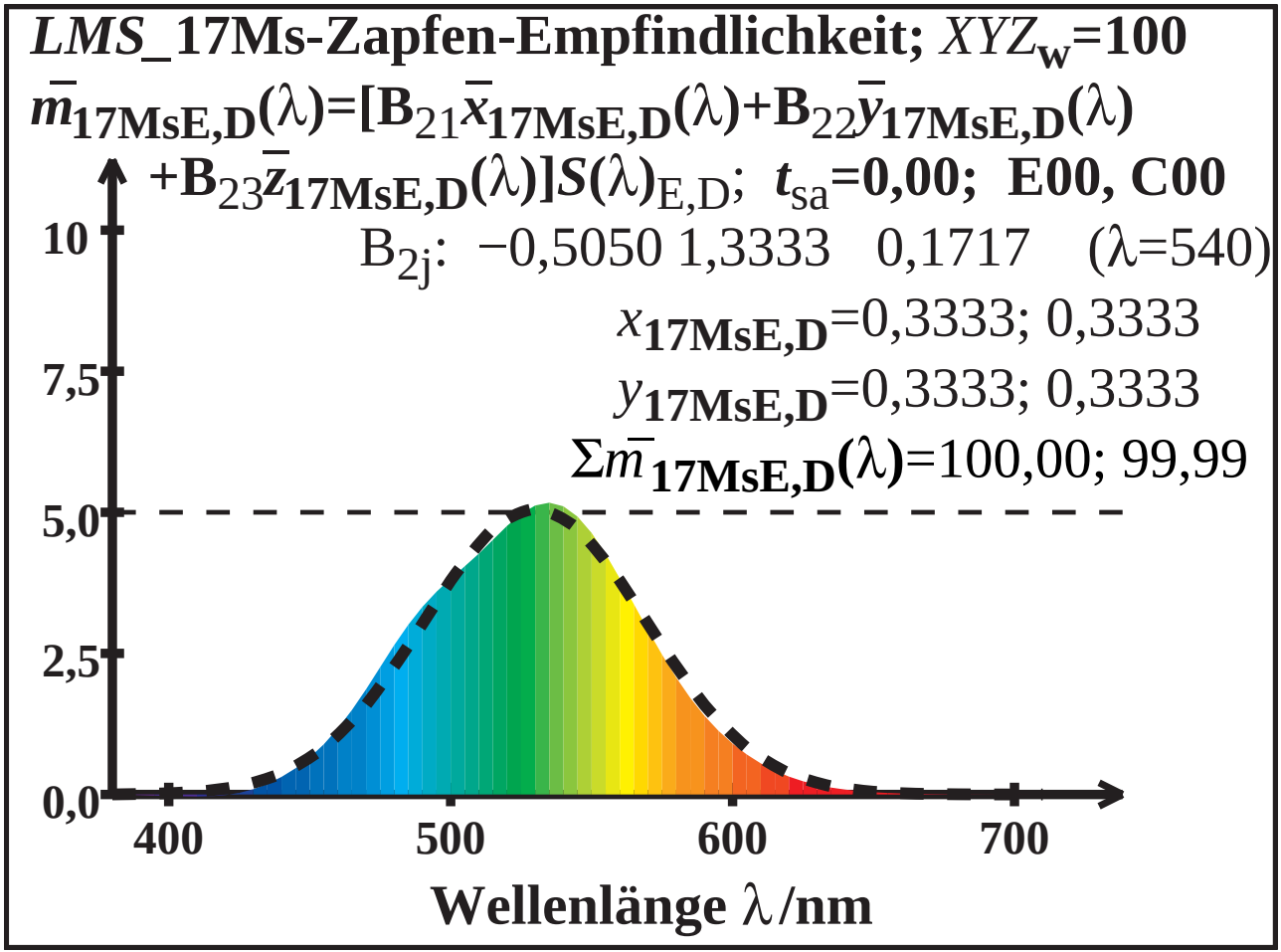
CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, A00
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

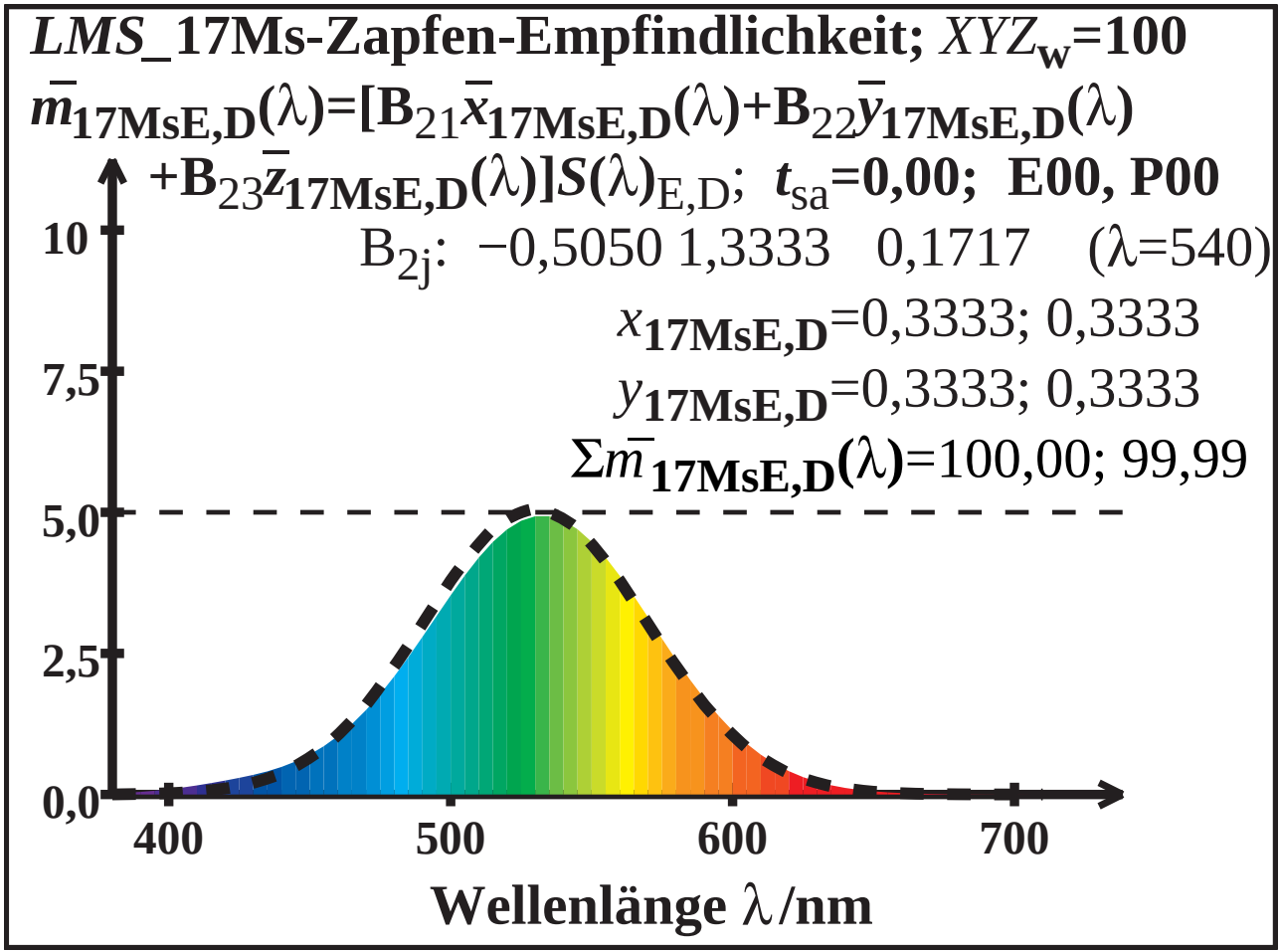
CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, E00
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

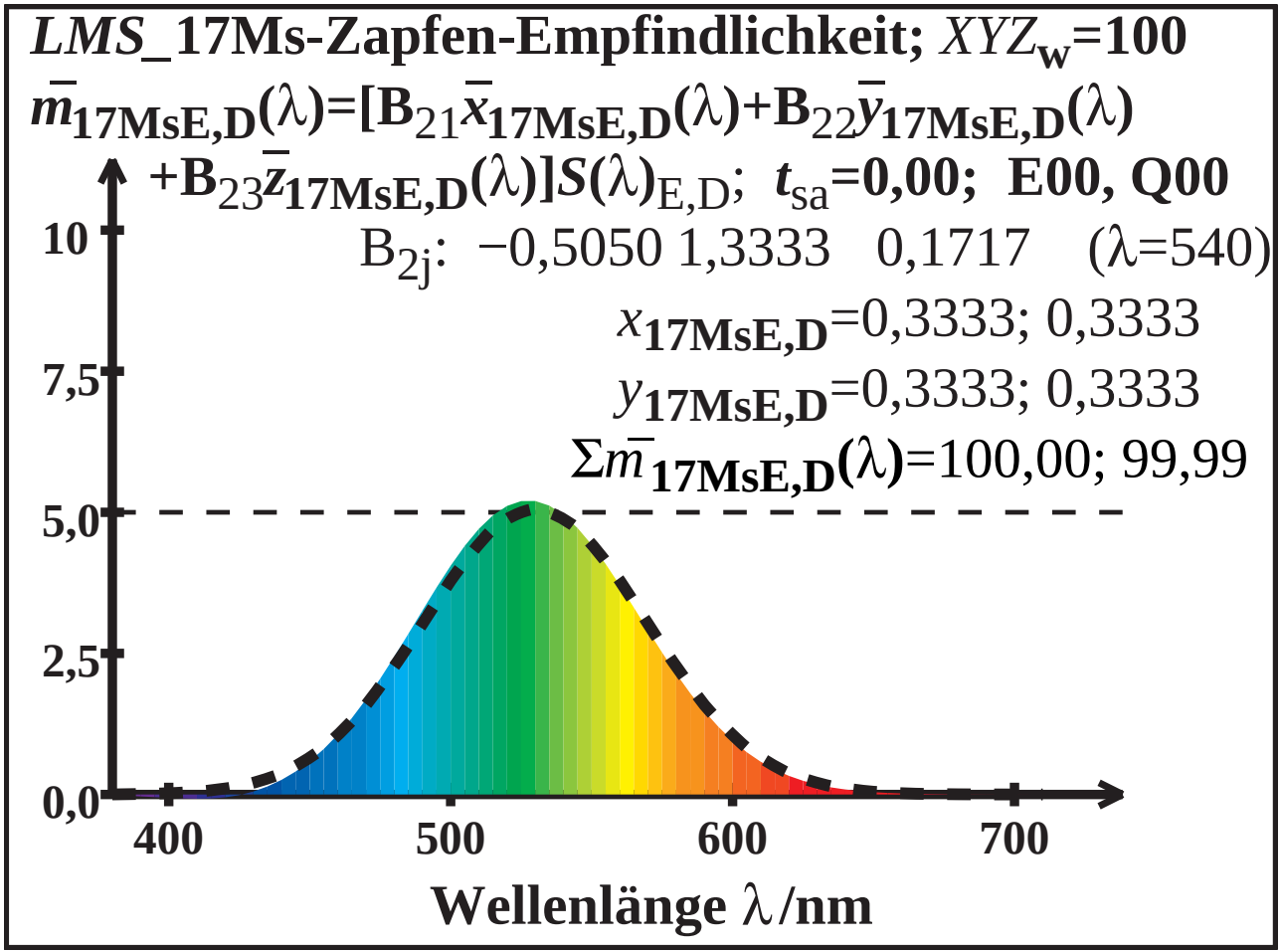
CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, C00
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m̄17MsE,D(λ)=[B21x̄17MsE,D(λ)+B22ȳ17MsE,D(λ)
+B23z̄17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, P00
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm̄17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

CG060−5A_1


LMS_17Ms-Zapfen-Empfindlichkeit; XYZw=100
m17MsE,D(λ)=[B21x17MsE,D(λ)+B22y17MsE,D(λ)
+B23z17MsE,D(λ)]S(λ)E,D; tsa=0,00; E00, Q00
B2j: −0,5050 1,3333 0,1717 (λ=540)
x17MsE,D=0,3333; 0,3333
y17MsE,D=0,3333; 0,3333
Σm17MsE,D(λ)=100,00; 99,99
10
7,5
5,0
2,5
0,0
400
500
600
700
Wellenlänge λ/nm

CG060−5A_1